

KISM 2025 BUSAN

Re:Innovation of Semiconductor Manufacturing for AI Ecosystem



(Hanyang Univ. / PeDiSem Ltd., Korea)



- 2025. Mar. Present: Hanyang University
 - Research Professor (Department of Electronic Engineering)
- 2013, Nov. 2025. Feb.: Applied Materials Korea
 - Senior Technical Director (Process Integration TD: Beyond scaling tech trends for DRAM, NAND, Foundry, Advanced Packaging & Process Integration for based module (Integrated Material Solution)
- 2012, Nov 2013, Nov: Samsung Electronics
 - Principal Engineer & Director (Vertical NAND Flash & Advanced Process Integration)
- 2009, Nov- 2012, Nov: Samsung Austin Texas LLC, USA
 - NAND Device Transfer and Production
- 1989, April 2009, Nov. Samsung Electronics
 - Principal Engineer & Director (SRAM/ NAND Flash & Advanced Process Integration)
- Over 35 years of experience in Semiconductor Process Integration, specializing in DRAM, NAND,
 Foundry and Advanced Packaging Technologies.
- Led key projects in DRAM/NAND/Foundry scaling, 3D IC packaging, and Cu-to-Cu hybrid bonding.
- Holder of 18 U.S. patents, around 50 Korea patents, abroad 9 papers and Korea 2 papers, and author of multiple international technical papers.

Education

- Mar.1984 Feb.1986 Master of Science in Physics, Hanyang University, Korea B.A. in Physics, Hanyang University, Korea
- Mar.1980 Feb.1984 B.A. in Physics, Hanyang University, Korea